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AMENDMEN Applicant(s): Tim Dye	TTAL LETTER (Large Entity) 1 2 2002				Docket No. 35013.4000		
Serial No. 5iling 199/836,426 April		Examiner McDonald, Shantese		se L.	Group Art Unit 3723		
Invention: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS FOR-REMOVING MATERIAL FROM A SURFACE OF A WORKPIECE THAT INCLUDES LOW-K MATERIAL APR 1 6 2002							
TO THE ASSISTANT COMMISSIONER FOR PATENTS: HNOLOGY CENTER R3700 Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.							
· CLAIMS AS AMENDED							
	MS REMAINING	HIGHEST #	D ·	NUMBER EXTRA CLAIMS PRESENT		ΓE	ADDITIONAL FEE
TOTAL CLAIMS	33 -	33 =			x \$	18.00	\$0.00
INDEP. CLAIMS	6 -	6 =	:	0	x \$	84.00	\$0.00
Multiple Dependent Claims (check if applicable)							\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT							\$0.00
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of A duplicate copy of this sheet is enclosed. □ A check in the amount of to cover the filing fee is enclosed. ☑ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-2814 A duplicate copy of this sheet is enclosed. ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. 							
Dated: 4/04/07							
Cynthia L. Pillote - Reg. No. 42,999 Snell & Wilmer LLP One Arizona Center							

400 E. Van Buren Street Phoenix, AZ 85004-2202

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I certify that this document and fee is being depositedn

April 4, 2002 with the U.S. Postal Service as firs with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Kristi Coplin

Typed or Printed Name of Person Mailing Correspondence

APR 1 2 700 MAILING BY FIRST CLASS U.S. MAIL

I hereby certify that this Response Pursuant to 37 C.F.R. 1.8 is being deposited with the United Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box Non-Fee Amendment, Washington D.C. 20231, on:

APR 1 6 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TECHNOLOGY CENTER R3700

Applicant(s): Tim Dyer, et al.

Attorney Docket No.: 35013.4000

Serial No.:

09/836,426

Group Art Unit:

3723

Filed:

April 17, 2001

Examiner:

McDonald, Shantese L.

TITLE:

CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS FOR REMOVING MATERIAL FROM A SURFACE OF A WORKPIECE

THAT INCLUDES LOW-K MATERIAL

RESPONSE

Commissioner for Patents Box Non-Fee Amendment Washington, D.C.

Dear Sir:

Applicants hereby timely respond to the Office Action mailed January 16, 2002, within the three-month shortened statutory period to respond. Please consider the following remarks.

REMARKS

In the January 16, 2002 Office Action, the Examiner acknowledged that claims 7-8, 11, 14-16, 21-23, and 29-31 include allowable subject matter and rejected claims 1-6, 9-10, 12-13, 17-20, 24-28, and 32-33. Applicants submit that all pending claims are allowable over the cited references and therefore request that the Examiner reconsider the claim rejections, in view of the arguments set forth herein, and allow all pending claims 1-33.